

Notice of References Cited	Application/Control No. 10/707,871		Applicant(s)/Patent Under Reexamination LIU ET AL.	
	Examiner Ernest Unelus		Art Unit 2181	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0193776	10-2003	Bicknell et al.	361/685
*	B	US-6,483,107	11-2002	Rabinovitz et al.	250/239
*	C	US-2005/0089027	04-2005	Colton, John R.	370/380
*	D	US-2003/0033477	02-2003	Johnson et al.	711/114
*	E	US-2005/0223269	10-2005	Stolowitz, Michael C.	714/006
*	F	US-2005/0204078	09-2005	Steinmetz et al.	710/038
*	G	US-2005/0160319	07-2005	Marcak et al.	714/032
*	H	US-2005/0120170	06-2005	Zhu, Qiming	711/114
*	I	US-2004/0210584	10-2004	Nir et al.	707/010
*	J	US-2005/0143694	06-2005	Schmidt et al.	604/304
*	K	US-7,065,661	06-2006	Borsini et al.	713/300
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.